

**IN THE SPECIFICATION:**

Please delete the title "ACIDIC POLISHING SLURRY FOR THE CHEMICAL-MECHANICAL POLISHING OF  $\text{SiO}_2$  ISOLATION LAYERS" on page 1 of the application and on the abstract and replace with the following:

**—METHOD FOR POLISHING A COMPOSITE MATERIAL CONTAINING SILICA AND SILICON NITRIDE WITH AN ACIDIC POLISHING SLURRY—.**

A new Abstract Page is enclosed.

Mo-6646D

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